## Application/Control No. Applicant(s)/Patent Under Reexamination 10/528,125 HELLER ET AL. Notice of References Cited Art Unit Examiner Page 1 of 1 Edna Wong 1753 **U.S. PATENT DOCUMENTS** Date **Document Number** Name Classification Country Code-Number-Kind Code MM-YYYY US-6,652,730 11-2003 Lehmkuhl et al. 205/236 Α US-3,969,195 07-1976 Dotzer et al. 205/103 В US-С US-D US-Ε US-F US-G US-Н USı USj US-Κ US-US-М **FOREIGN PATENT DOCUMENTS Document Number** Date Country Name Classification Country Code-Number-Kind Code MM-YYYY DE 19855666 A1 06-2000 LEHMKUHL et al. Germany C25D 3/44 Ν 0 Ρ Q R s Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U ٧ W

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